



Serial No. 10/717,934
OKI.597
Amendment dated August 4, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Makoto Terui et al.

Group Art Unit: 2823

Serial No.: 10/717,934

Examiner: W. Brewster

Filed: November 21, 2003

Confirm No.: 7542

For: METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE HAVING A
HEAT RADIATION LAYER

AMENDMENT

U.S. Patent and Trademark Office
Customer Window, **Mail Stop Amendment**
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Date: August 4, 2005

Sir:

In response to the Office Action dated March 7, 2005, the period for response having been extended two (2) months to August 7, 2005, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

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Remarks/Arguments begin on page 11 of this paper.